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**MAR 26 2006**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: Xu et al. 10/694,828  
 Appl. No.: ~~10/046,574~~ GPAU.: 2823  
 Filed: 27 October 2003 Examiner: Toledo, Fernando L  
 Docket No.: PA94-36-03 Conf. No.: 2766  
 For: Methods for Fabricating Patterned Features Utilizing Imprint Lithography

**AMENDMENT**

Commissioner for Patents  
 P.O. Box 1450  
 Alexandria, VA 22313-1450

Sir:

In response to the Office action mailed 22 December 2005 with a three-month shortened statutory period response of 22 March 2006 and extended hereby to 22 April 2006 by the enclosed Petition for Extension of Time, Applicants respectfully request that the application be amended as follows:

**Amendments to the Claims** begin on page 2 of this paper

**Remarks/Arguments** begin on page 6 of this paper.

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02 FC:2251 60.00 DA

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